Docket No.: H6808.0039/P039

Claims 1-7. (Canceled)

8. (New) A method for measuring the dimensions of patterns formed on a sample on the basis of a line profile which is obtained from an image formed by the electrons emitted from the patterns on the samples scanned with electron beams comprising:

AMENDMENTS TO THE CLAIMS

for the obtained line profile, detecting edges of the patterns according to a predetermined first edge position detecting method and calculating distances between the detected edges according to a predetermined first measuring method; and

for said line profile, establishing a second edge position detecting method and a second measuring method and measuring the dimensions of patterns according to the established second edge position detecting method and second measuring method.

- 9. (New) The method as claimed in claim 8, wherein the measuring methods include measurement of line widths and edge roughness of the line profile.
- 10. (New) A scanning electron microscope comprising a computer for measuring the dimensions of patterns formed on a sample on the basis of a line profile which is obtained from an image formed by the electrons emitted from the patterns on the samples scanned with electron beams, wherein

the computer is arranged to perform a plurality of edge position detecting methods and a plurality of measuring methods for calculating distances between detected edges;

the computer detects, for the obtained line profile, edges of the patterns according to a predetermined first edge position detecting method and calculates

distances between the detected edges according to a predetermined first measuring method; and

the computer establishes, for said line profile, a second edge position detecting method and a second measuring method.

- 11. (New) The scanning electron microscope as claimed in claim 10, wherein the measuring methods include measurement of line widths and edge roughness of the line profile.
- 12. (New) The scanning electron microscope as claimed in claim 10, further comprising a display means for displaying information about the edge position detecting methods and the measuring methods.